

# Coatings for the far UV

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# Outline

- Broadband mirrors at 100-1000 nm

  - Reflectance

  - Roughness

- Broadband mirrors down to  $\lambda < 100$  nm

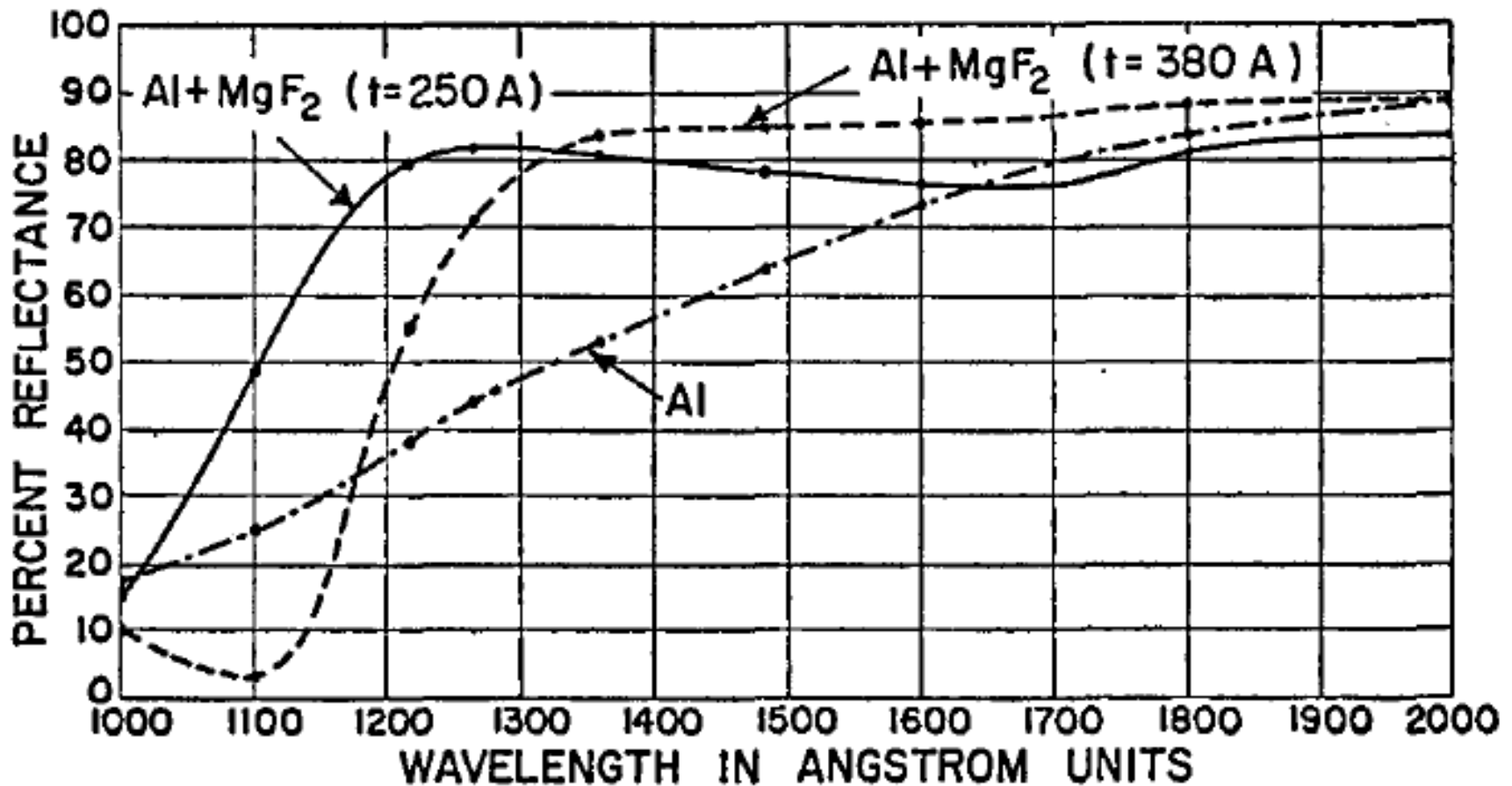
- Narrowband mirrors centered at  $\lambda > 100$  nm

- Narrowband mirrors centered at  $\lambda < 100$  nm

**GOLD**

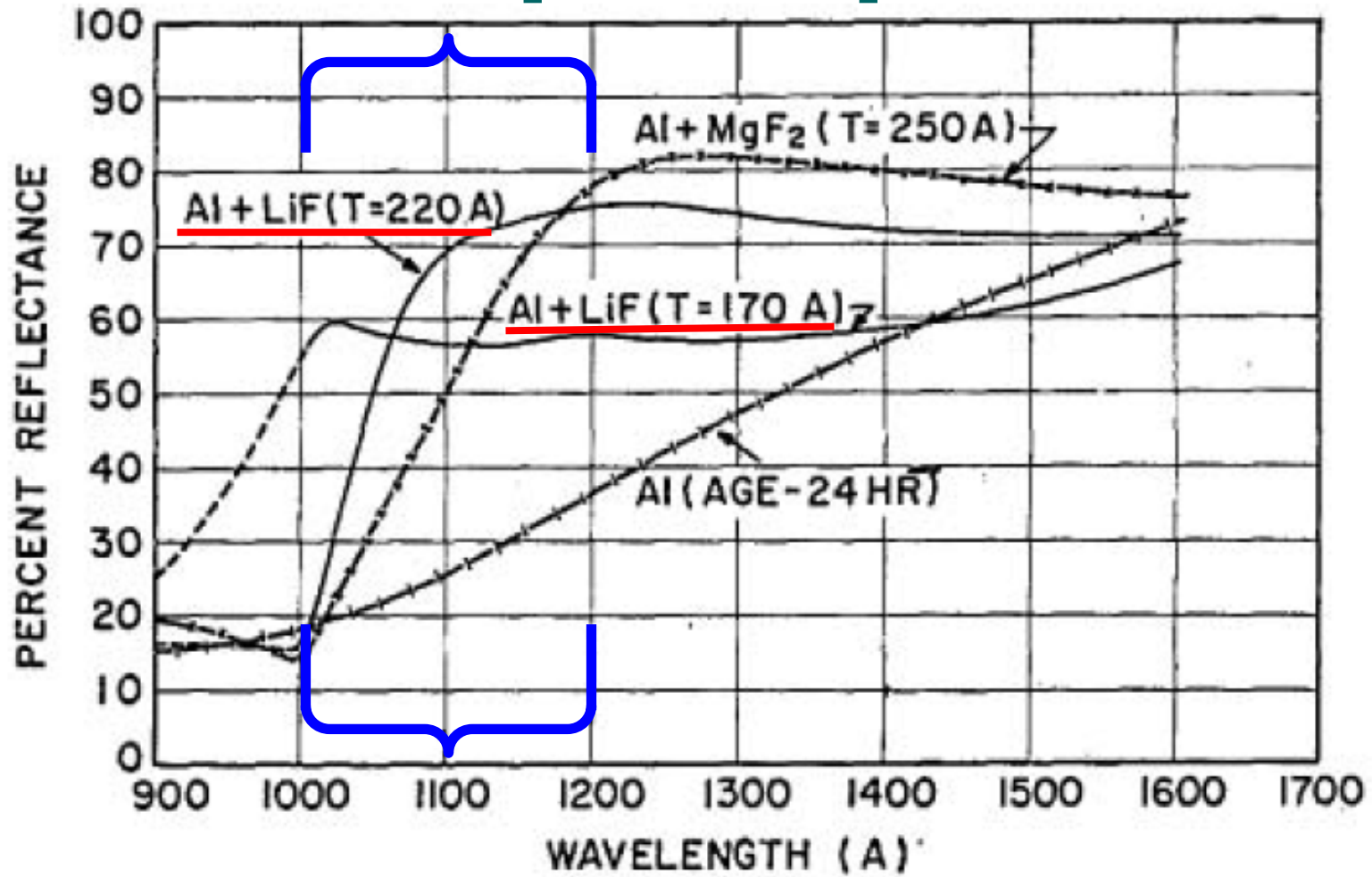


# Al protected with $\text{MgF}_2$ : the paradigm



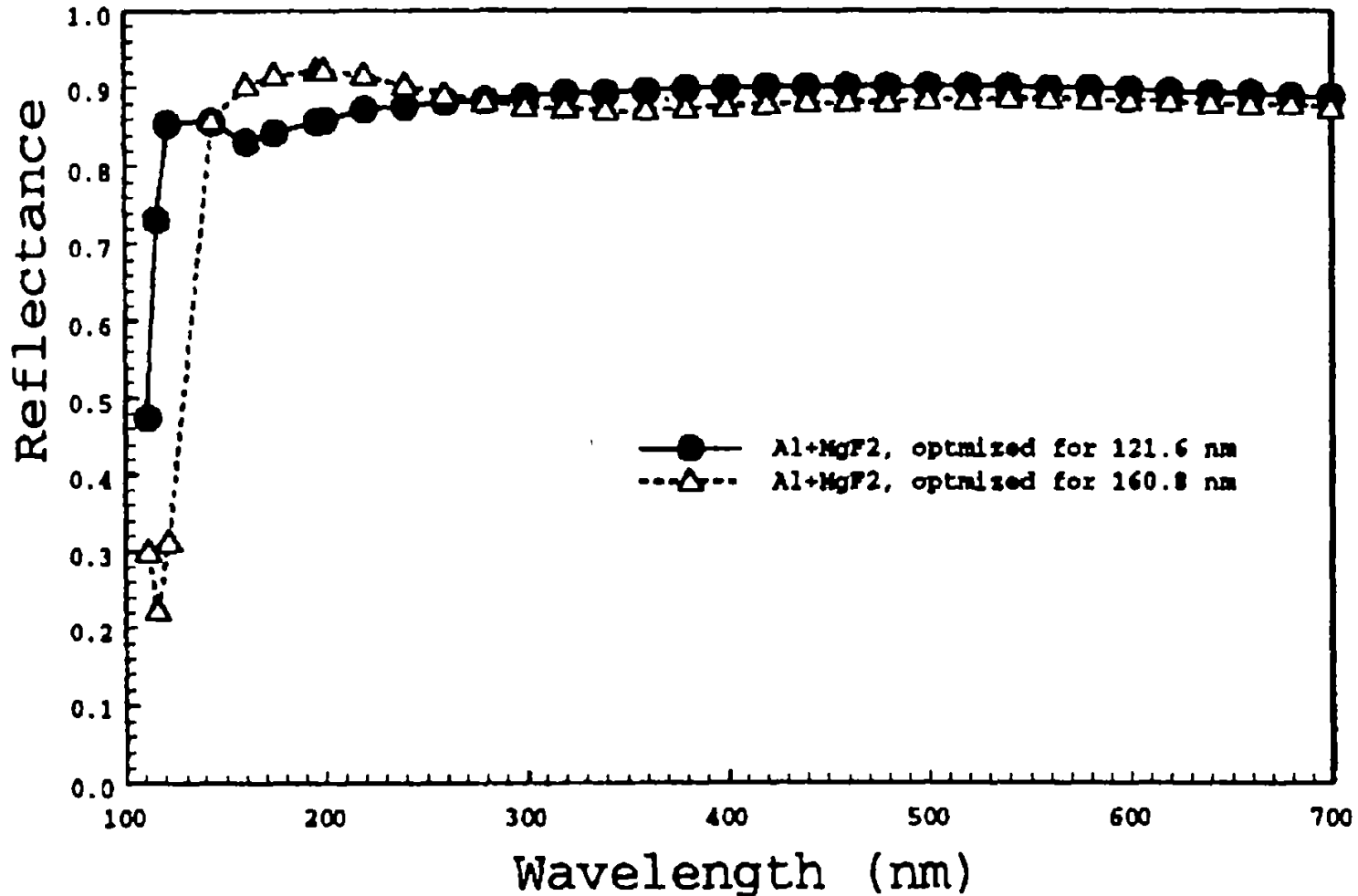
Hass & Tousey, J. Opt. Soc. Am. **49**, 593 (**1959**)

# Al protected with LiF: the paradigm at $\lambda \in [100-120]$ nm



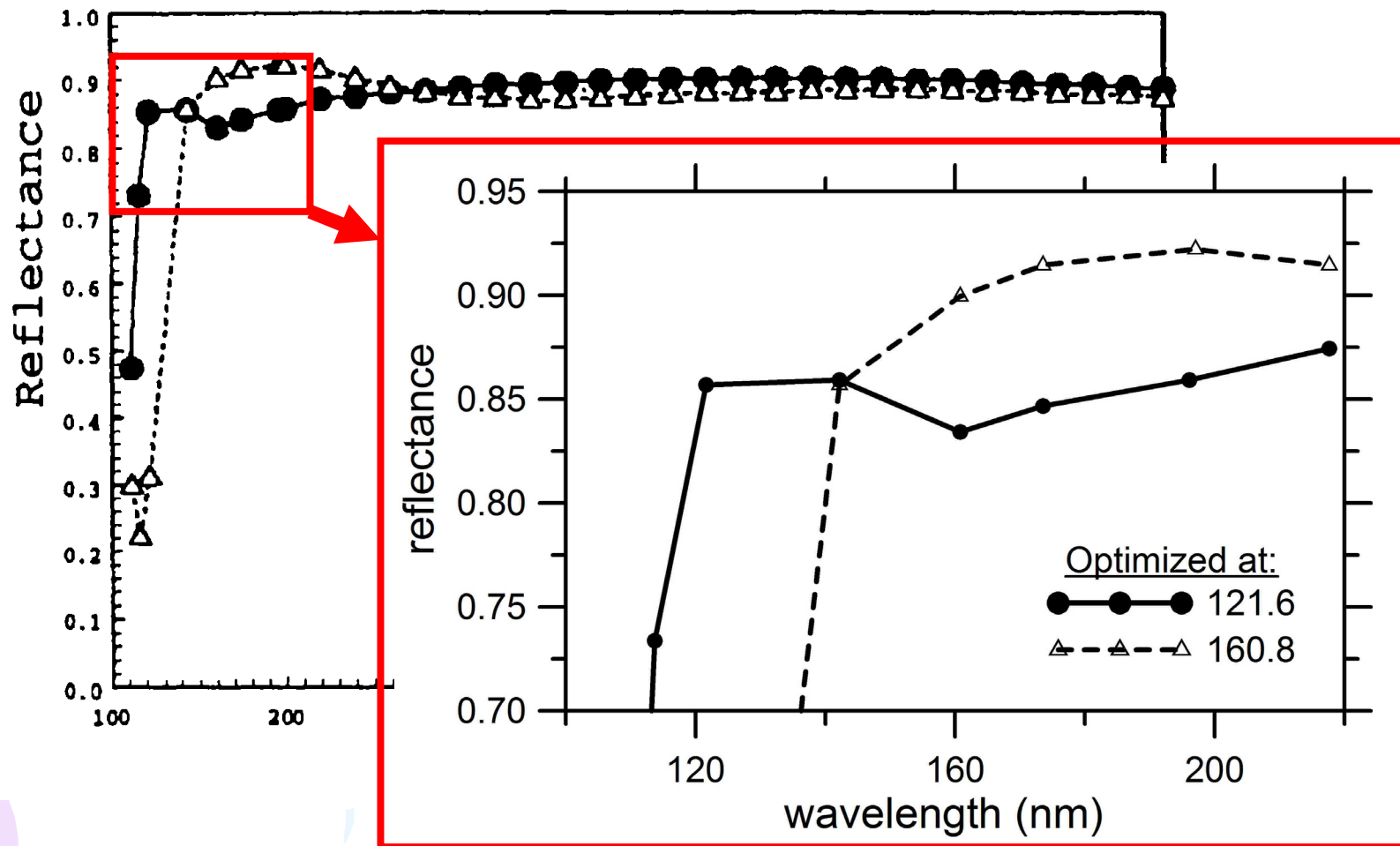
Angel et al. J. Opt. Soc. Am. **51**, 913 (1961)

# Al/ MgF<sub>2</sub>: improved Refl. due to cleaner techniques



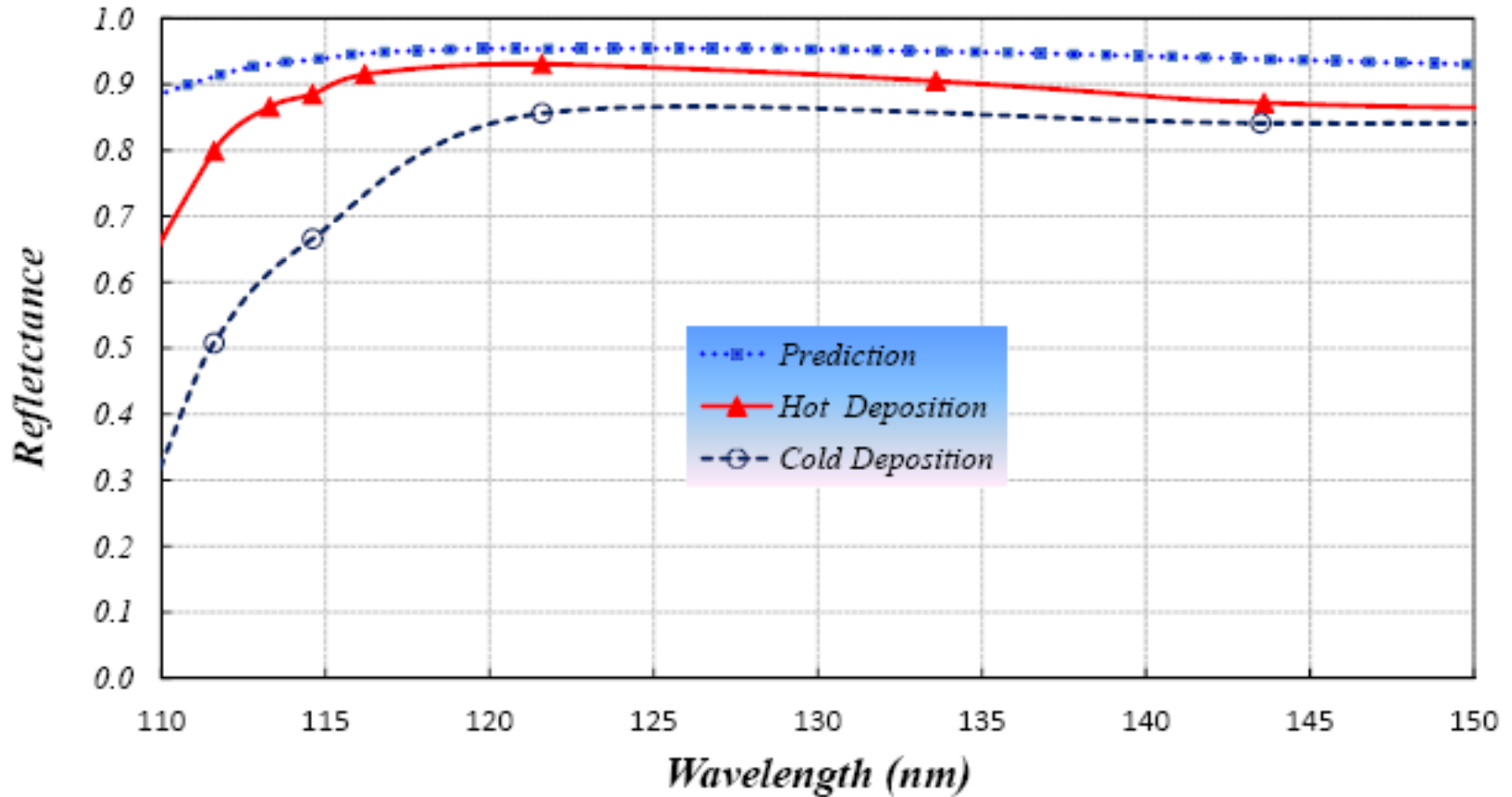
Keski-Kuha et al., ASP Conf. Ser. **164**, 406 (1999)

# Al/ MgF<sub>2</sub>: improved Refl. due to cleaner techniques



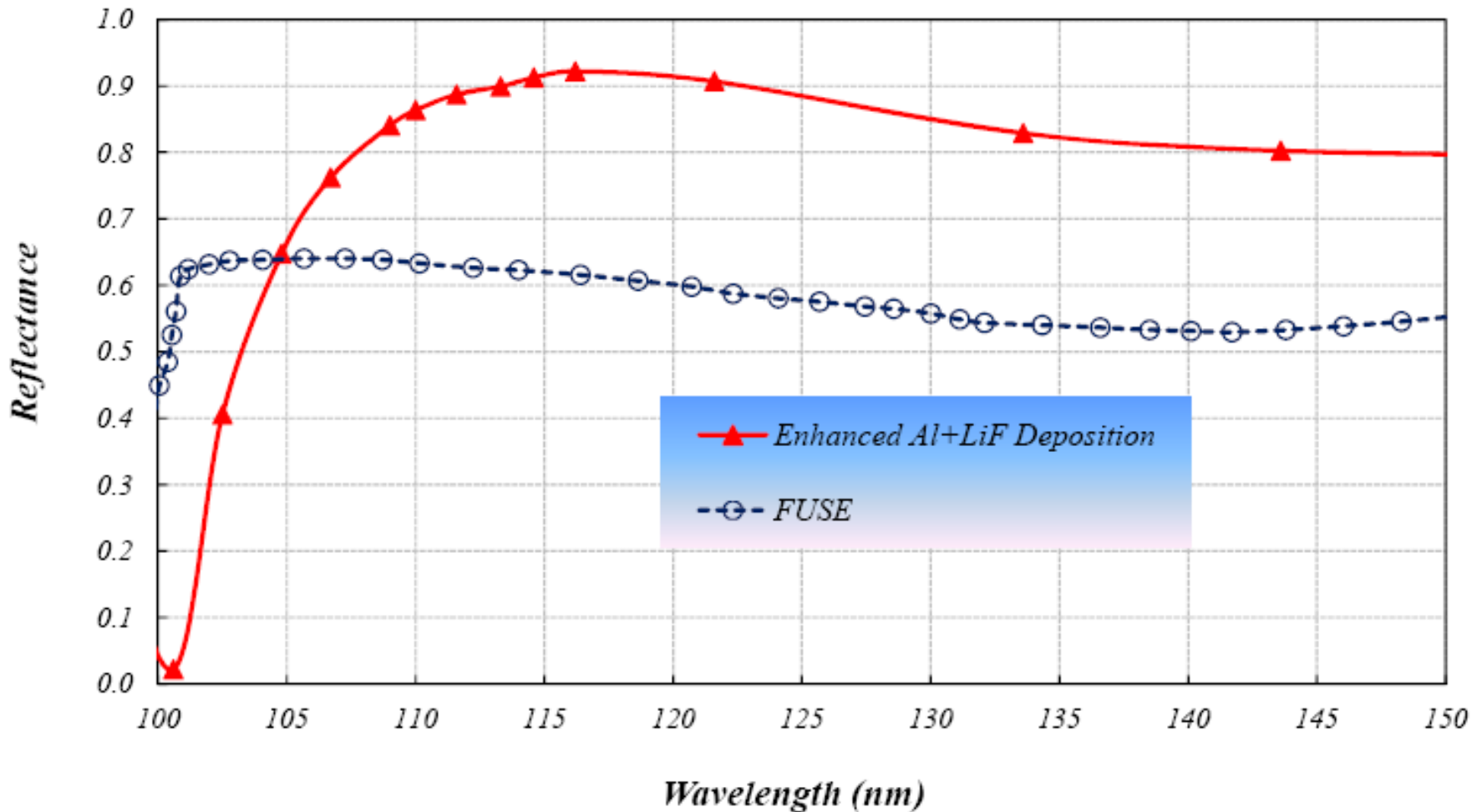
Keski-Kuha et al., ASP Conf. Ser. **164**, 406 (1999)

# Refl increase of Al+MgF<sub>2</sub>: MgF<sub>2</sub> deposited on hot (220°C) Al (+a little MgF<sub>2</sub>)



Quijada et al., Proc. SPIE **9144**, 91444G (2014)

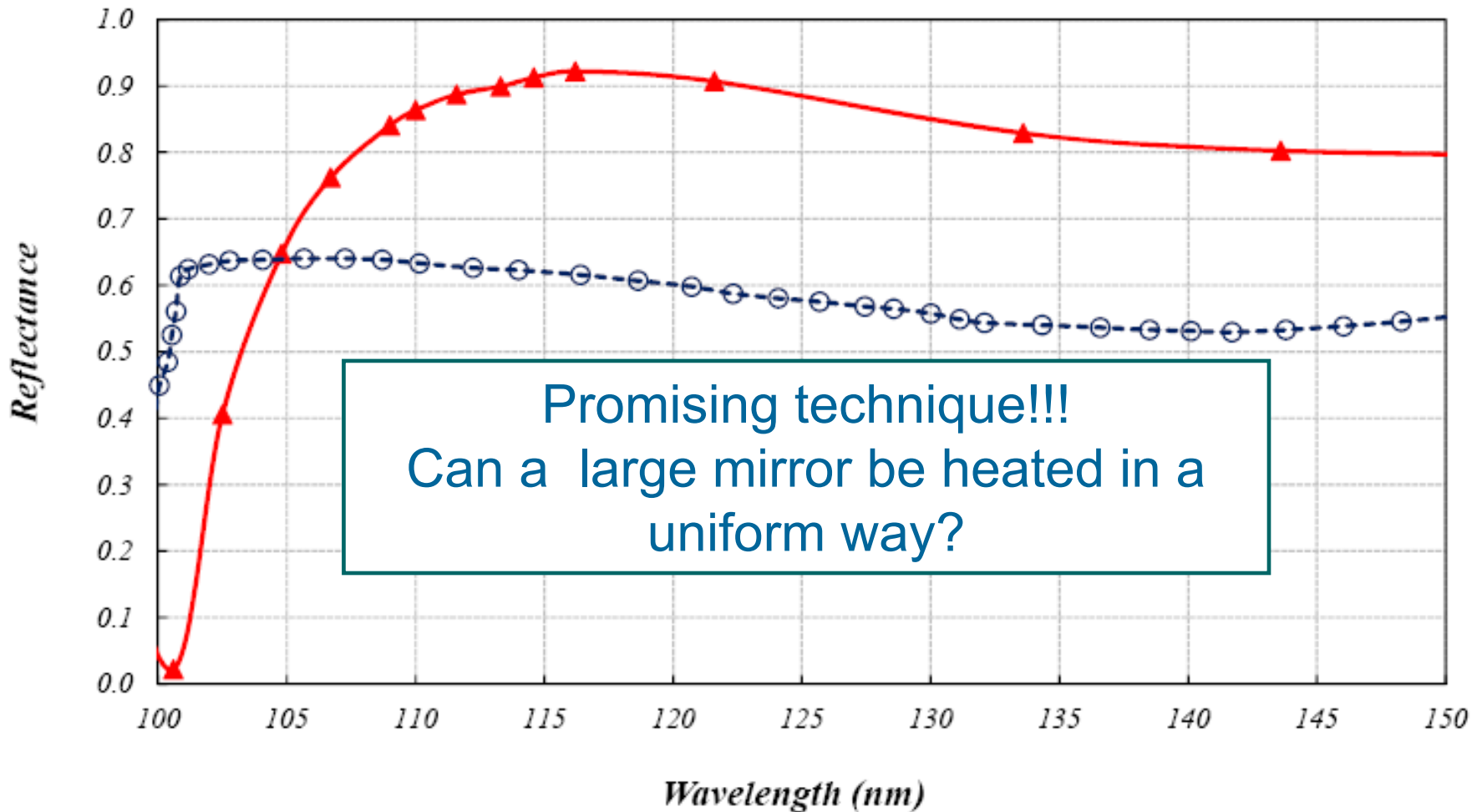
And the same for Al+LiF:  
LiF deposited on hot (250°C) Al (+a little LiF)



Quijada et al., Proc. SPIE **9144**, 91444G (2014)



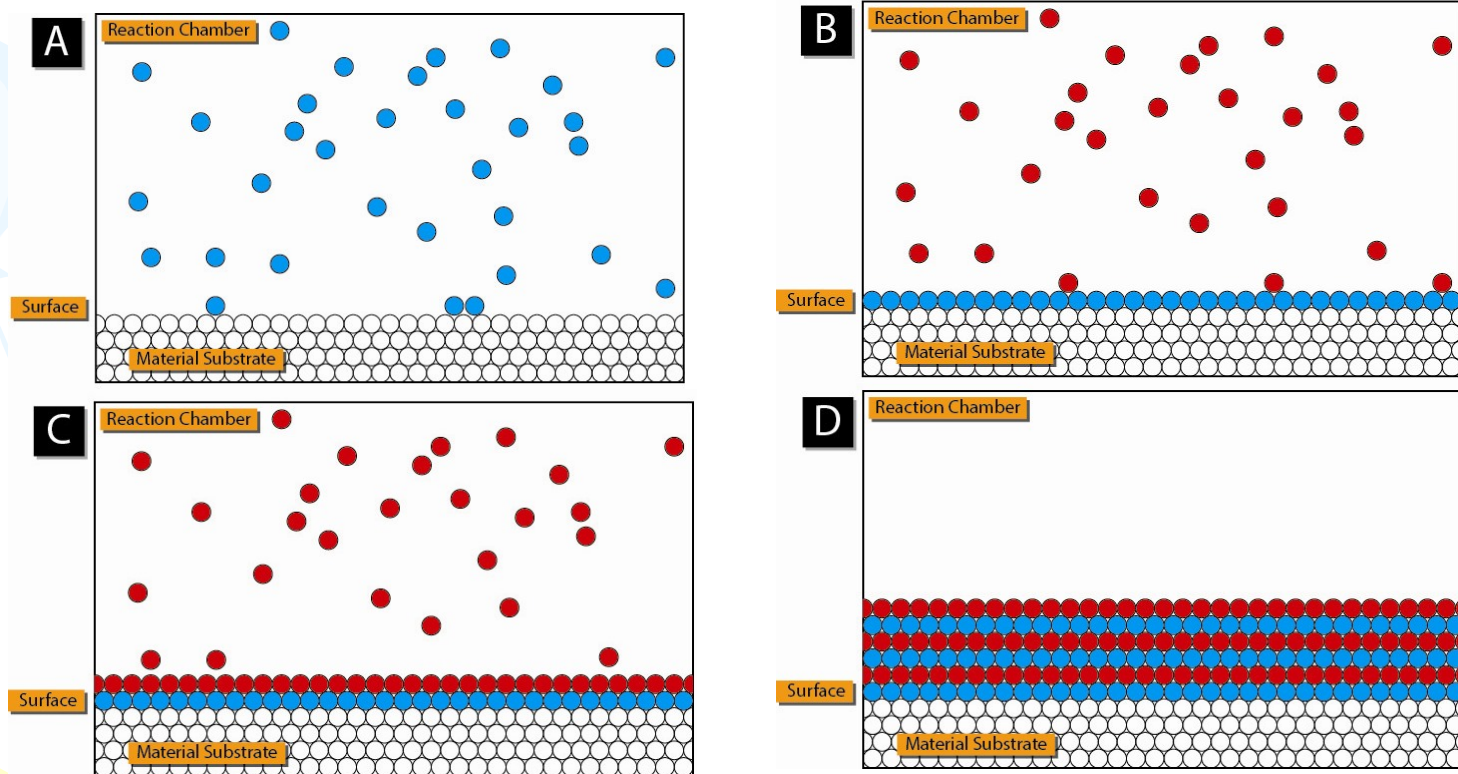
And the same for Al+LiF:  
LiF deposited on hot (250°C) Al (+a little LiF)



Quijada et al., Proc. SPIE **9144**, 91444G (2014)

# Can we use the magics of **Atomic Layer Deposition**?

- ALD: exposing substrate to alternate gases (precursors)
- One monolayer deposited in each cycle
- High uniformity
- **Without pinholes?**
- **Can we protect Al with an ultrathin ALD-MgF<sub>2</sub>?**



Source: wikipedia

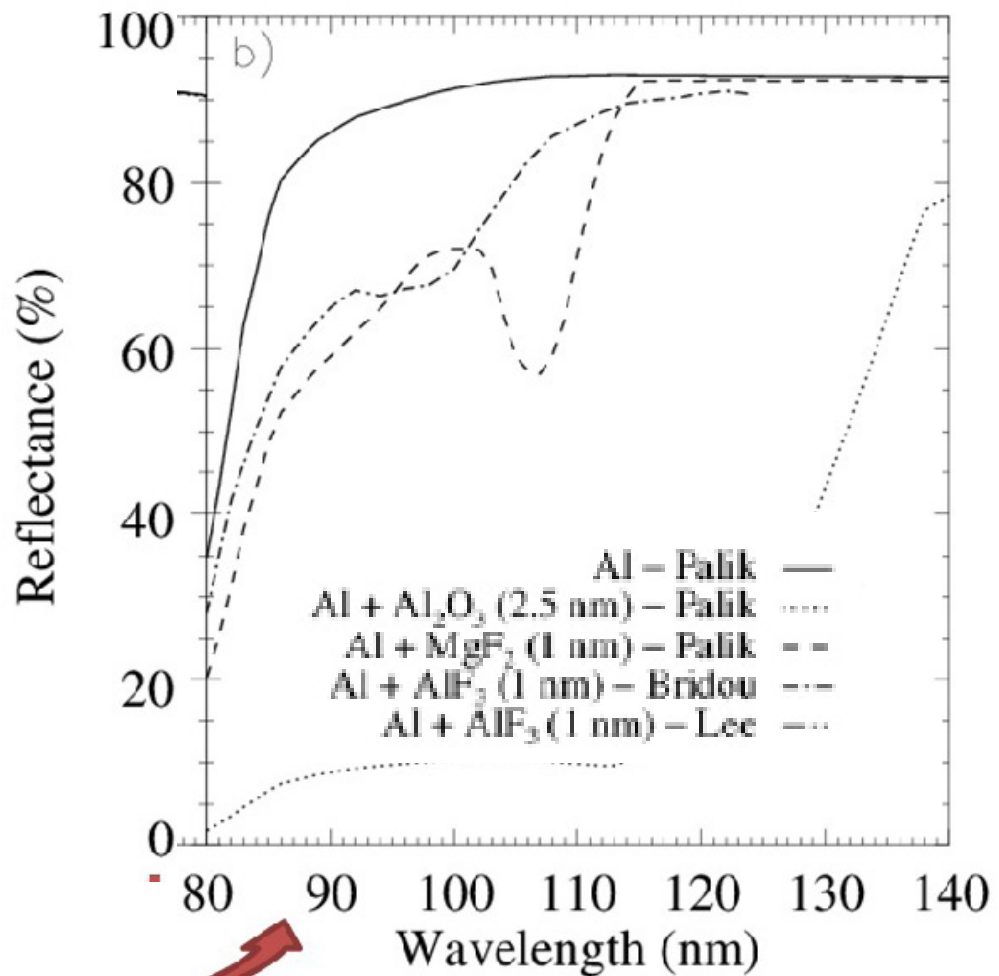
# Extended high Refl down to 90 nm: ultrathin protection (MgF<sub>2</sub> or AlF<sub>3</sub>) for Al

Sembach, Astro2010  
Technology

Development report:

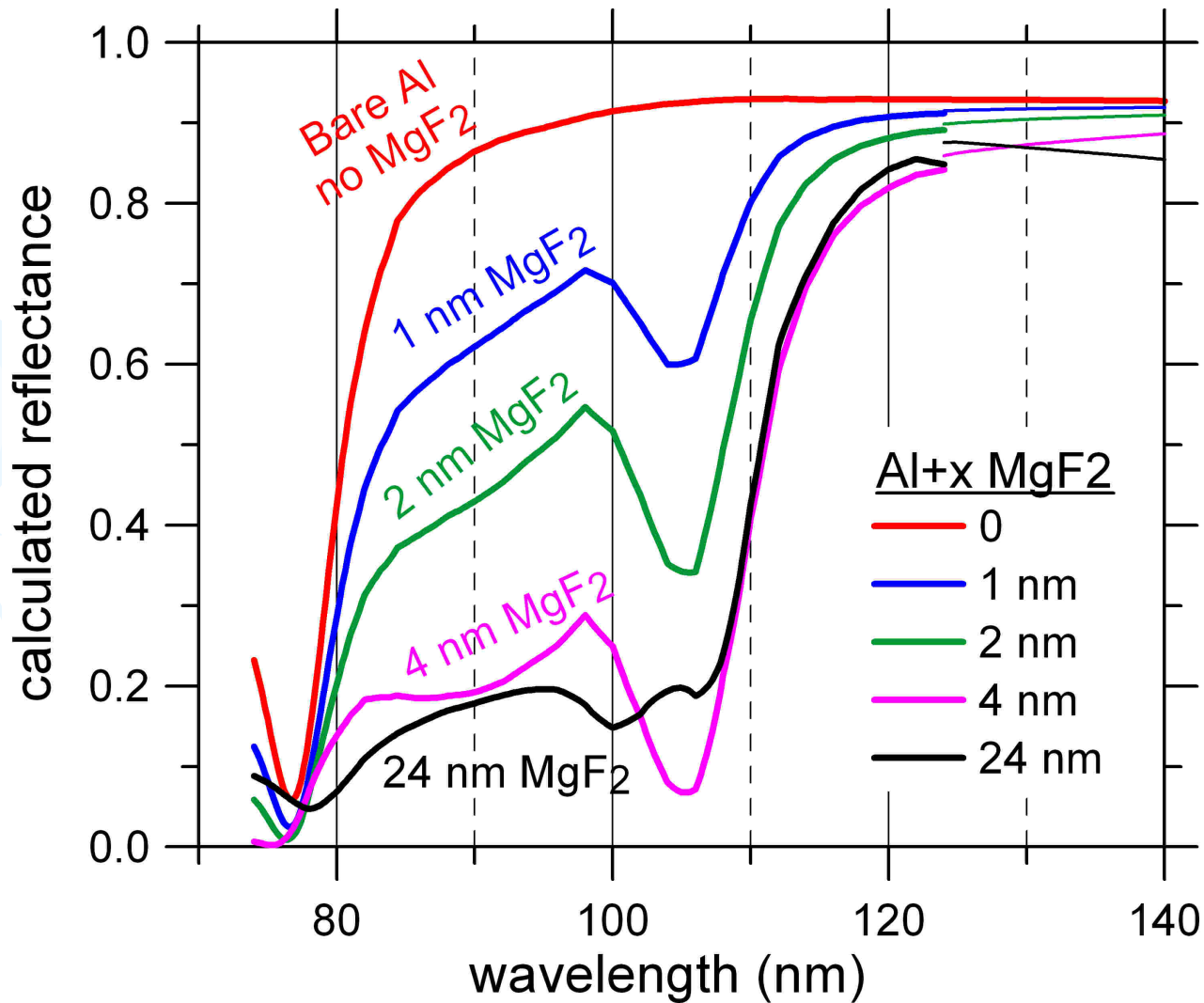
**Al protected with 1-  
nm thick ALD MgF<sub>2</sub>:**

*"if 1 nm layer of single-crystal MgF<sub>2</sub>...can be deposited uniformly on large optics and are stable, they may provide an avenue for high reflectivity in the UV"*

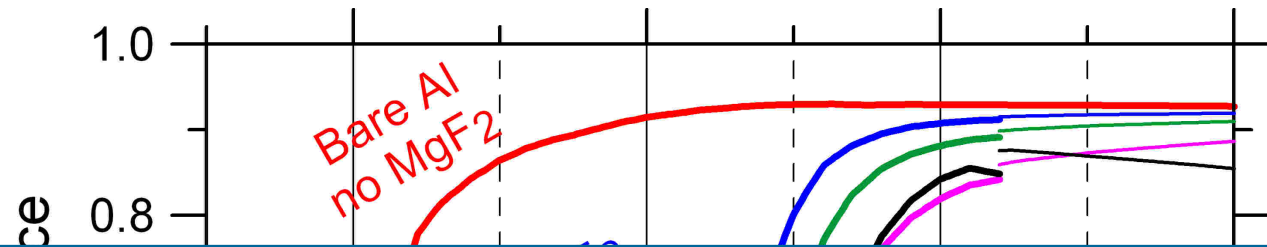


Moore et al., Proc. SPIE **9144**, 91444H (2014)

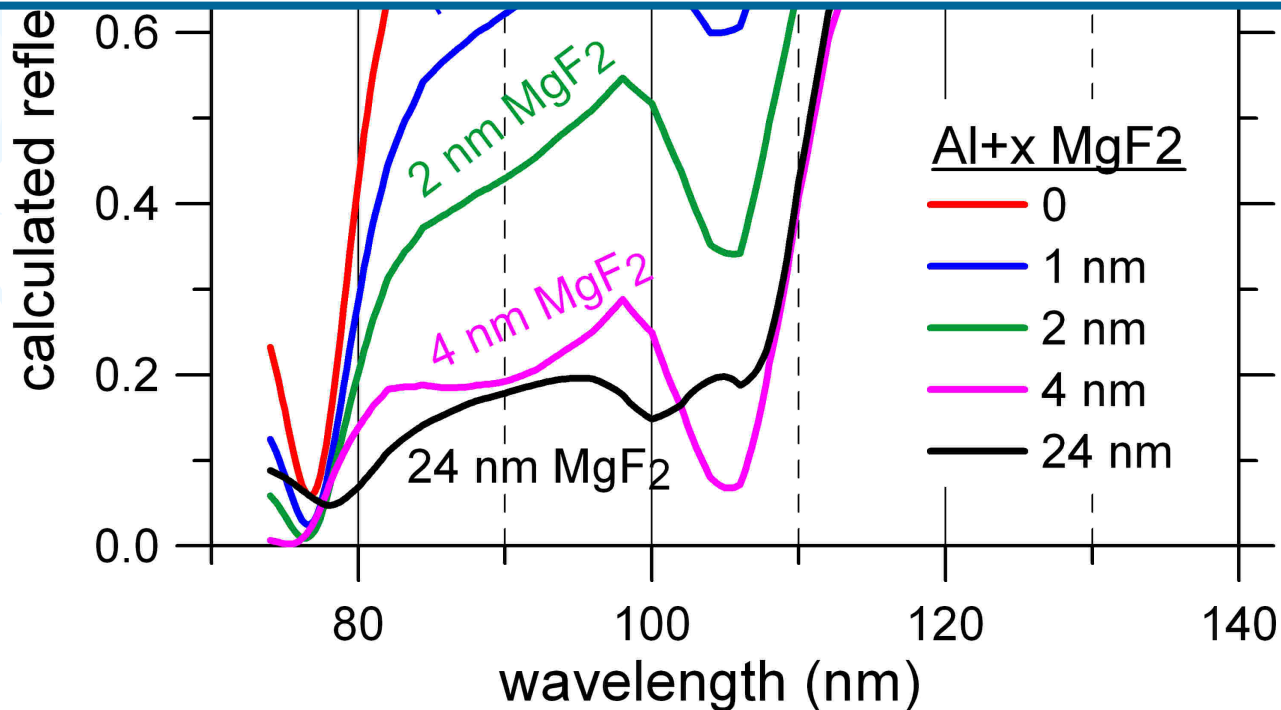
# Extended high Refl down to 90 nm: ultrathin protection of MgF<sub>2</sub> for Al



# Extended high Refl down to 90 nm: ultrathin protection of MgF<sub>2</sub> for Al



**Can we fully protect Al with such an ultrathin film?**



# ALD $\text{MgF}_2/\text{AlF}_3$ to protect Al: difficulties

$\text{MgF}_2$ : Pilvi et al., J. Mater. Chem. **17**, 5077 (2007):

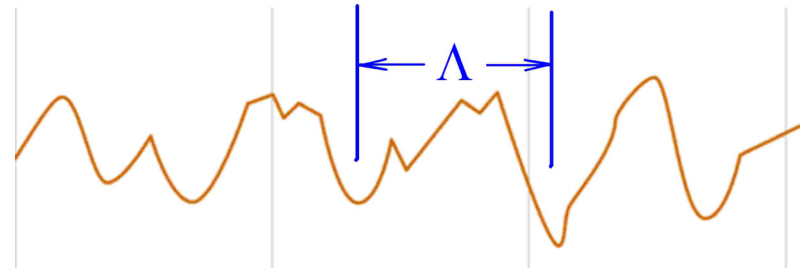
- .- Purity strongly depends on temperature: 80% at 250 C; 99.7% at 400 C
- .- Roughness increases with temperature
- .- ...” the impurity levels are not low enough for really high transmission in vacuum UV”

Can we keep a bare Al film free from oxidation over the first ALD cycles?

**Promising technique...,  
but needs to demonstrate feasibility**

# Roughness of Al films: importance of grain width

Roughness effects depend on lateral size  $\Lambda$  of roughness



1.  $\Lambda < \lambda$ : absorption; surface plasmons  
Coatings produce mostly this roughness

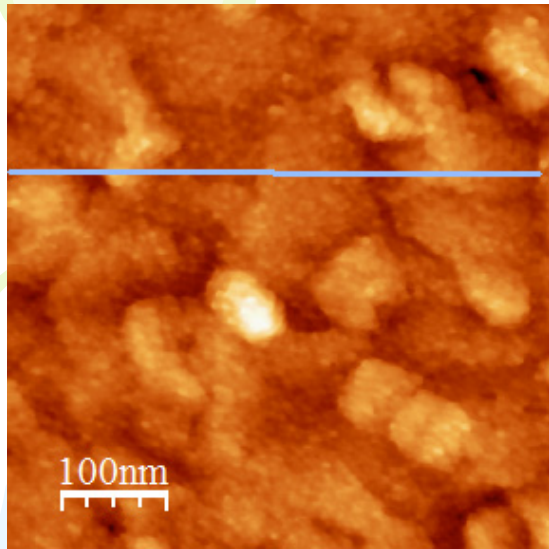
2.  $\Lambda > \lambda$ : **scattering**

Most contribution comes from substrate (polishing)

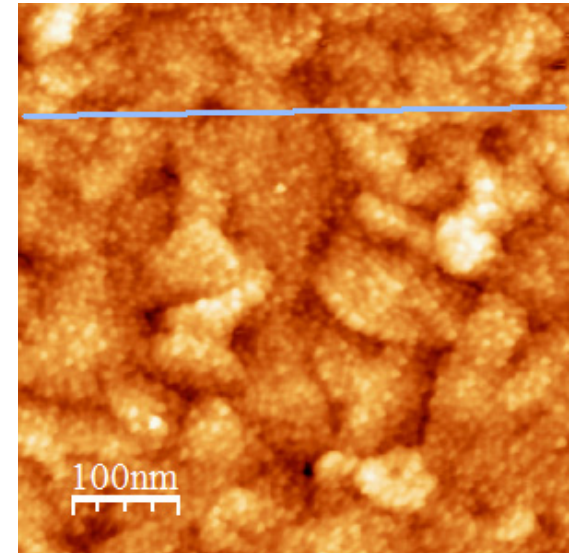
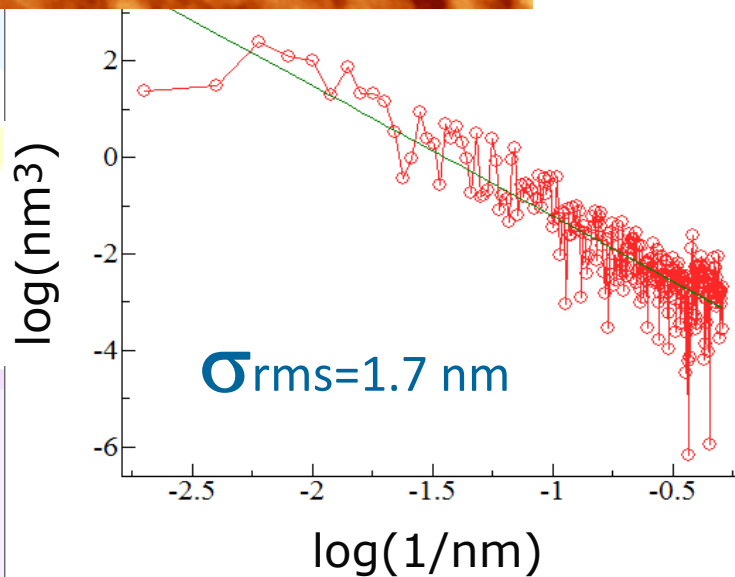
Contribution No. 2 is more destructive, such as for internal coronagraphy



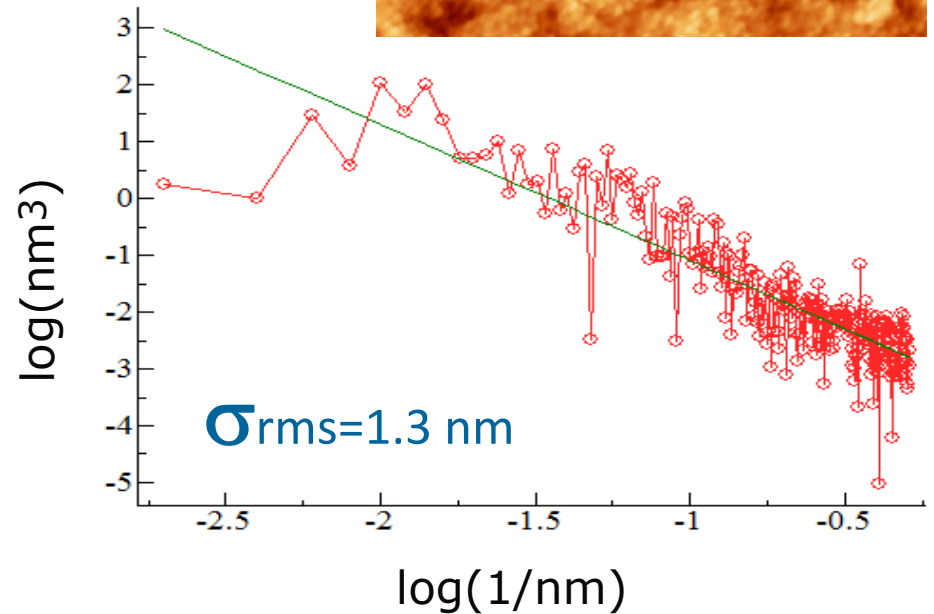
# Roughness of Al/MgF<sub>2</sub> films



Top  
MgF<sub>2</sub> at  
RT



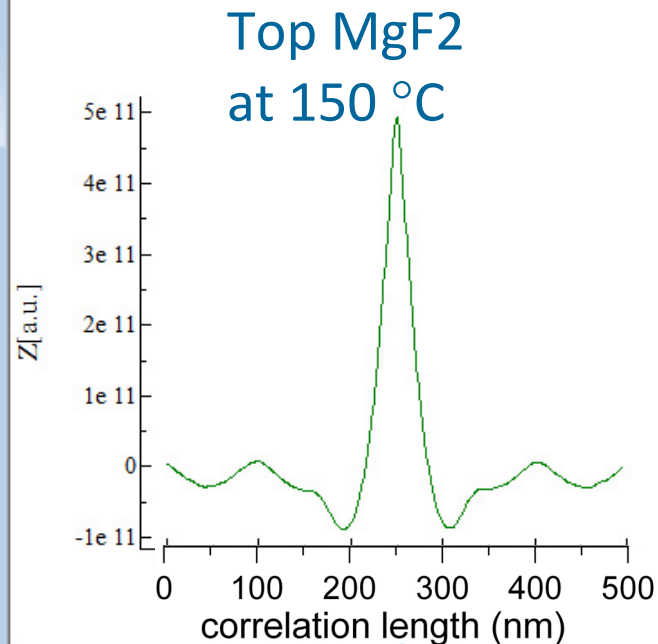
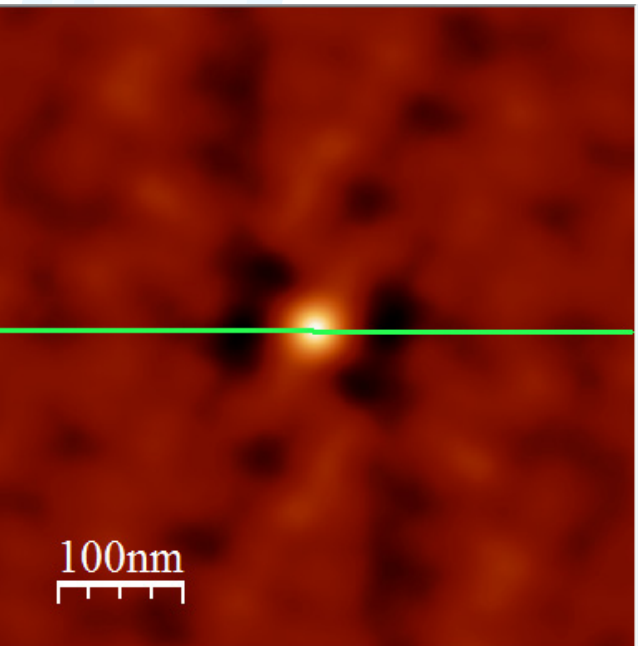
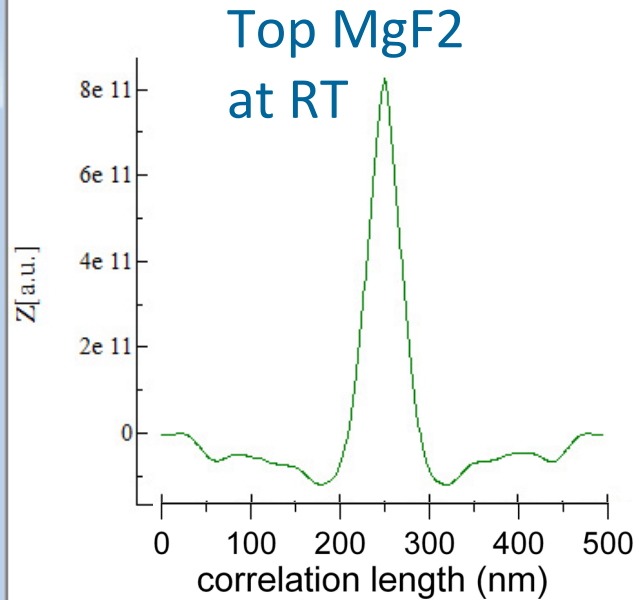
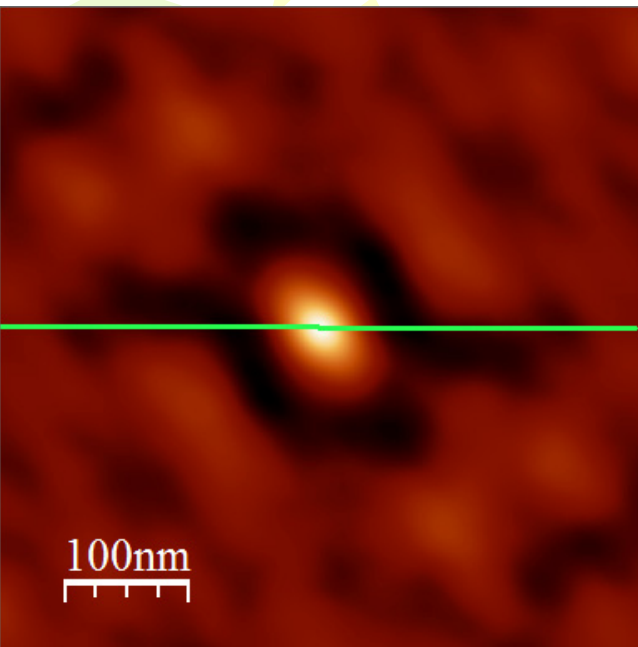
Top  
MgF<sub>2</sub> at  
150 °C



Source: GOLD-Instituto de Optica



# Roughness of Al/MgF<sub>2</sub> films



Grain width:  
 $\sim$  or  $< \lambda$

# Can we minimize roughness of Al films?

- ✓ Maybe by amorphization of Al! 😊

Soufli et al., Appl. Phys. Lett. **101**, 043111 (2012)

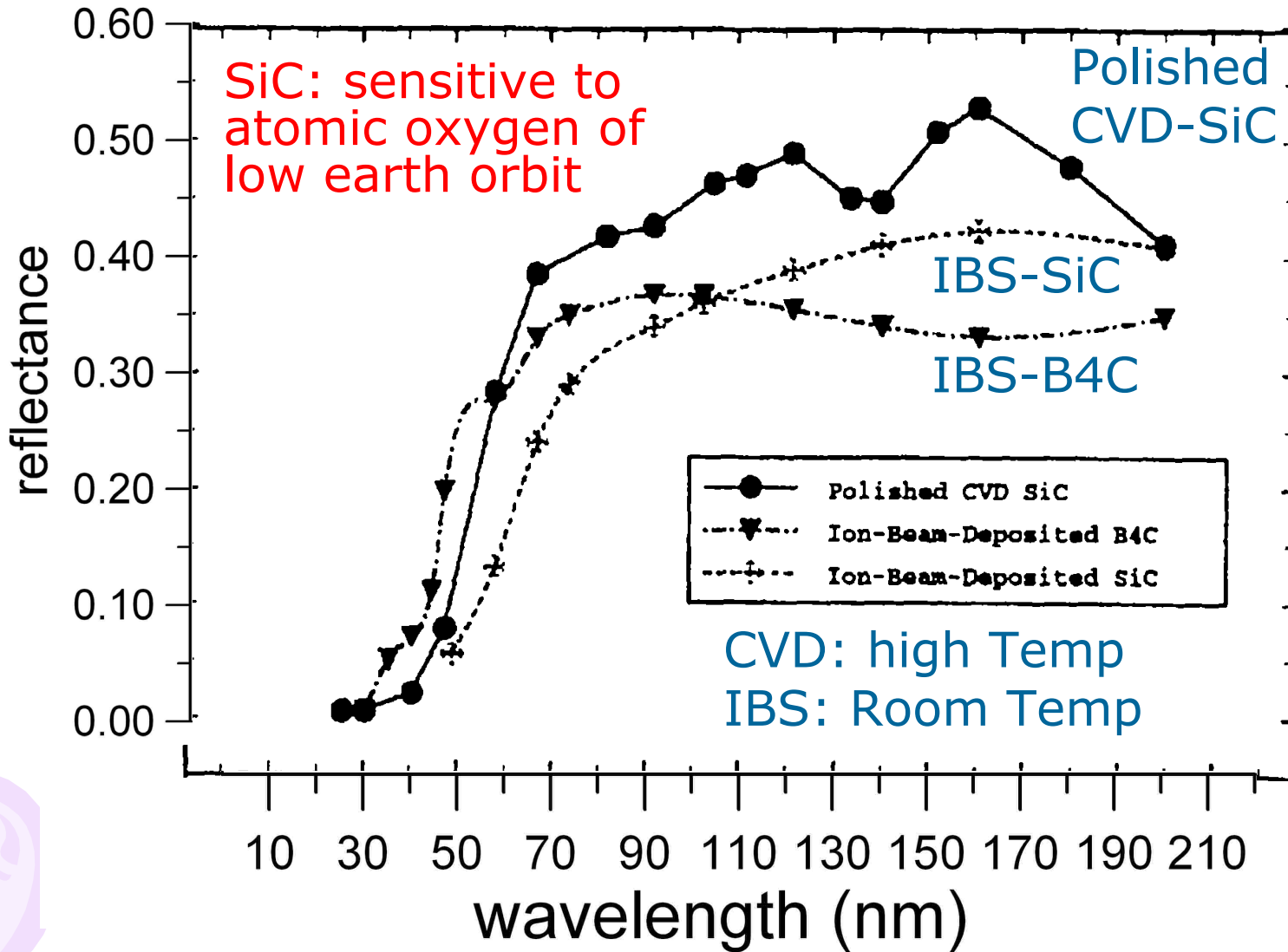
**Sputter-deposited Al on Mg**: spontaneously intermix to form a **partially amorphous** layer

“The intermixed layer consists of sparse Al and Mg crystallites embedded in a matrix of amorphous Al-Mg material”.

“The average **crystallite size is reduced by 70% for Al** and by 45% for Mg”.

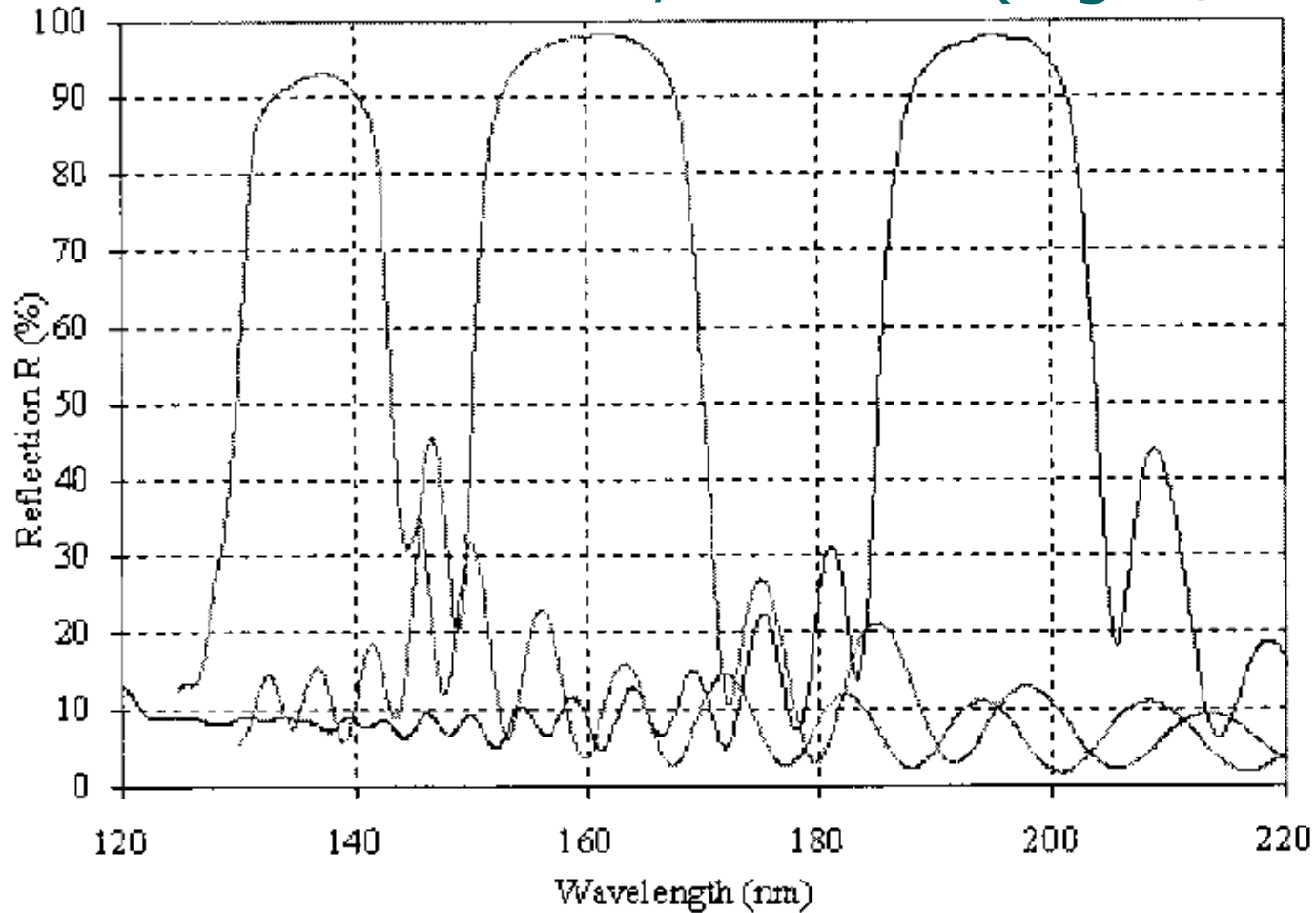
“amorphous films have **better passivating properties** than crystalline ones due to reduced grain boundaries, vacancies, and defects”

# Broadband mirrors: down to $\lambda < 100$ nm



# Narrowband mirrors centered at $\lambda > 120\text{nm}$

MLs with two fluorides, such as  $(\text{MgF}_2/\text{LaF}_3)_n$

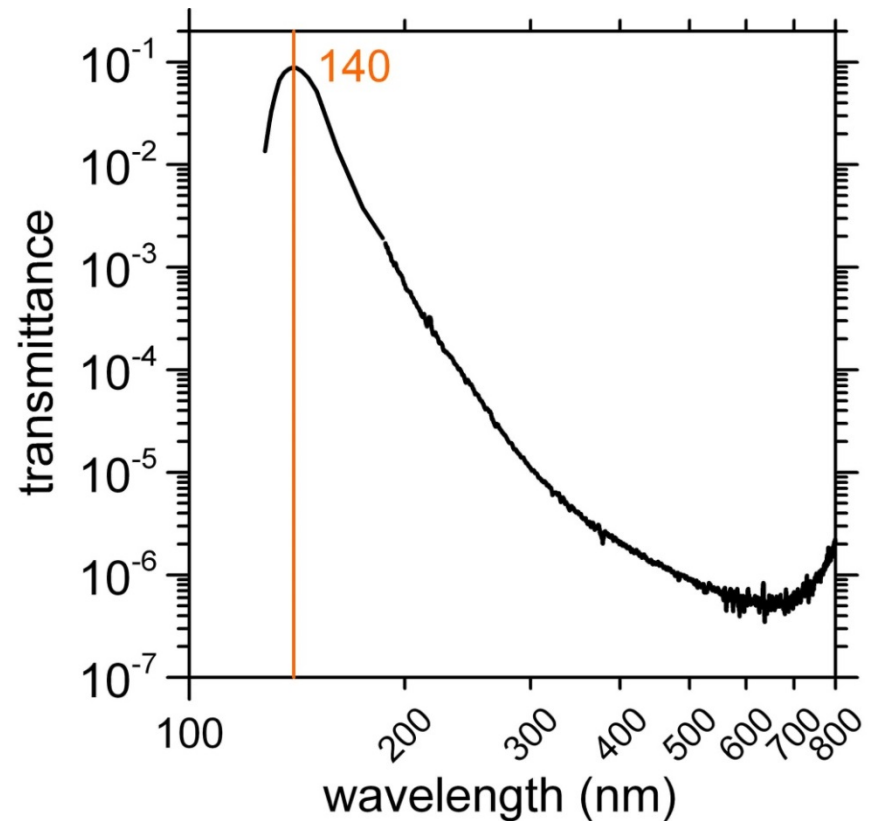
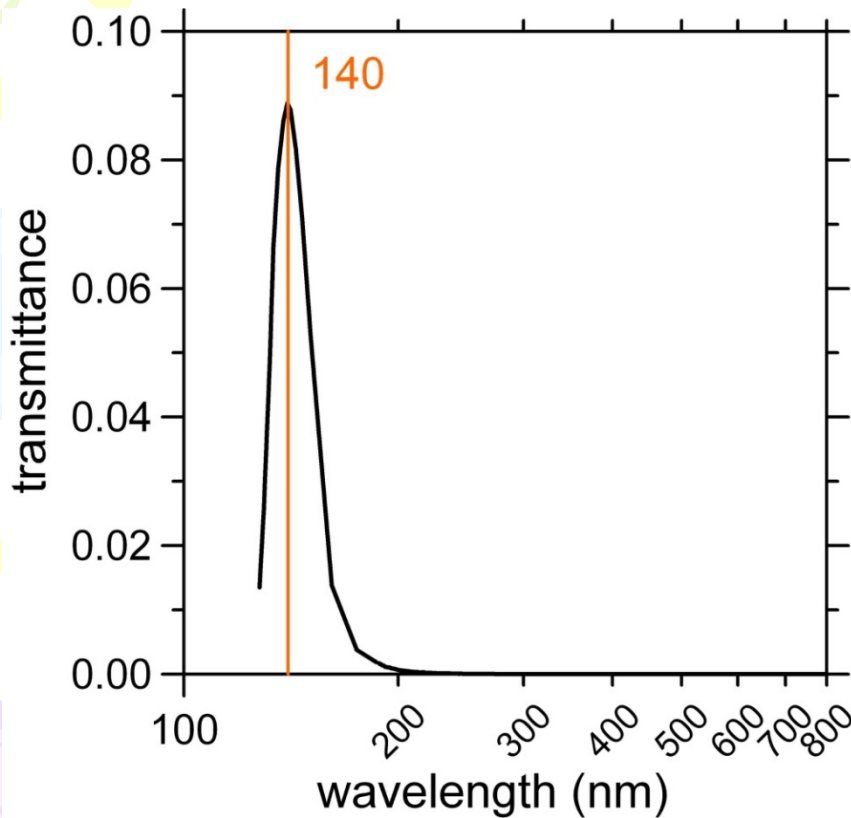


Gatto et al., Appl. Opt. **41**, 3236 (2002)

NB mirrors peaked at 120 nm (GOLD-Instituto de Optica)

# Transmittance filters: peaked at $\lambda > 120$ nm

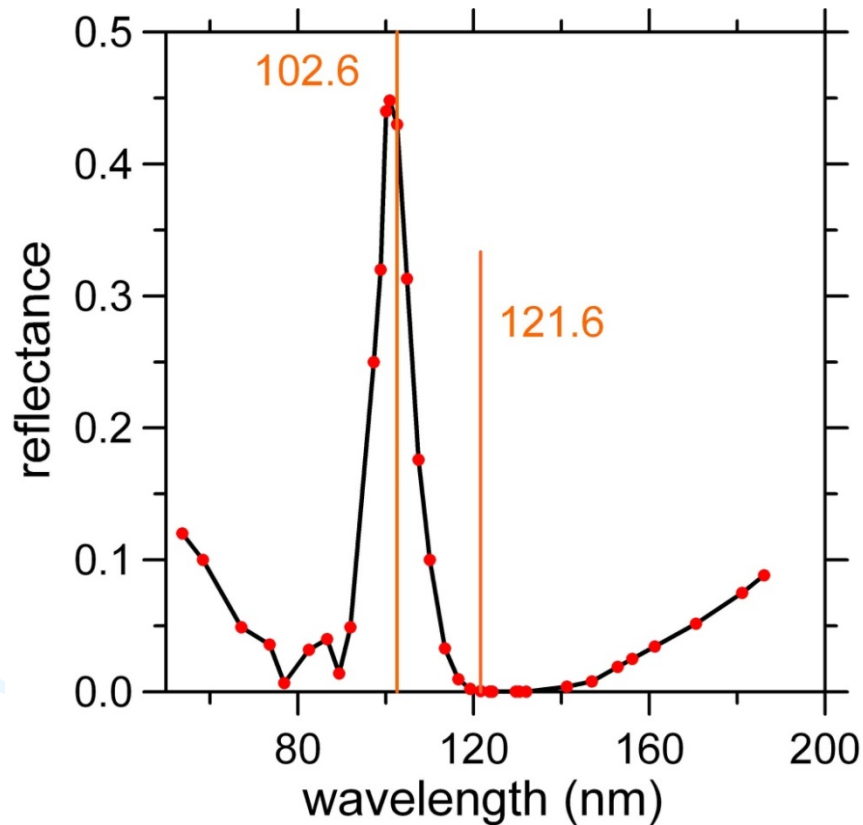
$(\text{Al}/\text{MgF}_2)_n$  on a transparent substrate



Source: GOLD-Instituto de Optica

# Narrowband mirrors centered at $\lambda \sim 100\text{nm}$ Al/LiF/SiC/LiF ML

Imaging solar corona: **Ly $\beta$**  much weaker than **Ly $\alpha$**

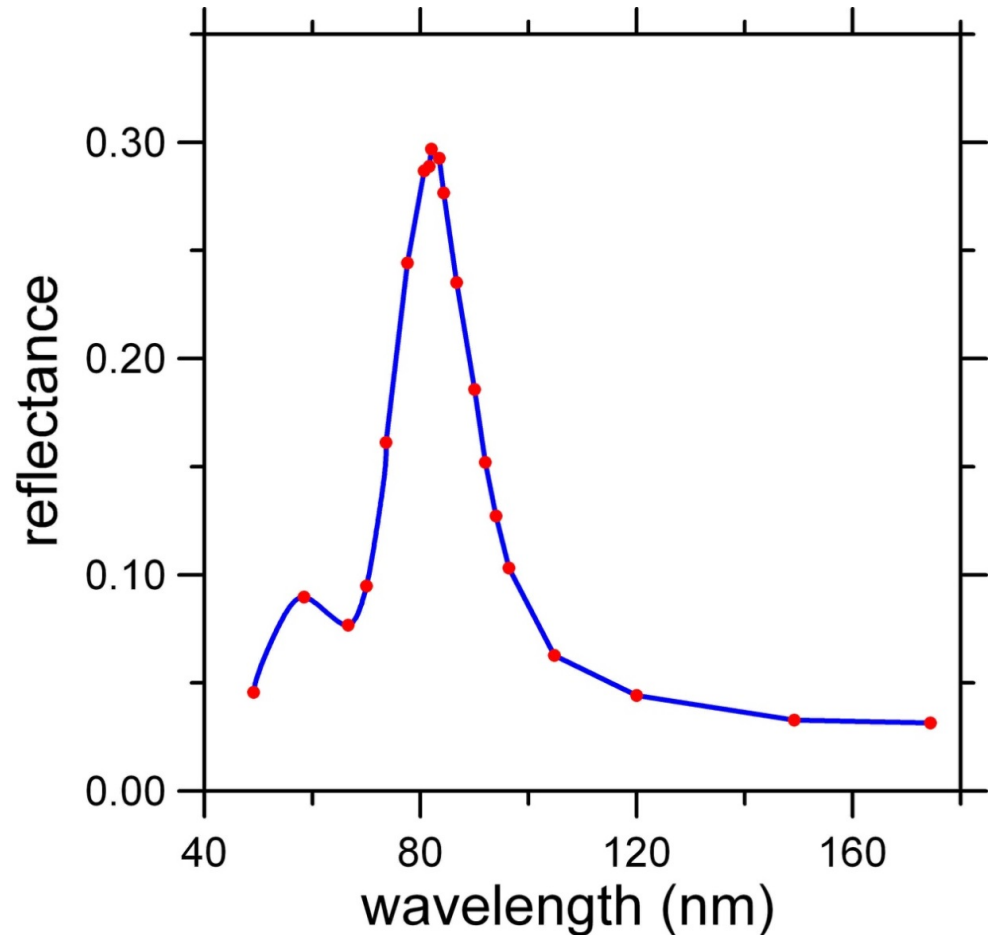


Rodríguez de Marcos et al., Proc. SPIE **8777**, 87771E (2013)

# Narrowband coatings at $\lambda < 100$ nm

Materials strongly absorb in  $60 \text{ nm} < \lambda < 100 \text{ nm}!!$

Eu/SiO/Al/SiO ML





# Summary

Al/MgF<sub>2</sub> keeps the paradigm:

- Refl enhancement by heating: could be mature in few years
- Refl extension to  $\lambda=90$  nm with ultrathin MgF<sub>2</sub>: needs to demonstrate feasibility

## Acknowledgments

Spanish Programa Nacional de  
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AYA2013-42590-P